

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor:	<b>John Mize et al.</b>
Serial No:	<b>10/542040</b>
Filed:	<b>February 6, 2006</b>
For:	<b>APPARATUS AND METHODS FOR IONIZED DEPOSITION OF A FILM OR THIN LAYER</b>

Examiner:	<b>Jason Berman</b>
Art Unit:	<b>1795</b>

**RESPONSE TO OFFICE ACTION**

**MAIL STOP AMENDMENT  
COMMISSIONER OF PATENTS  
P.O. Box 1450  
ALEXANDRIA, VA 22313-1450**

Dear Sir:

This paper responds to the Office Action dated February 11, 2009. Please enter the following:

**CLAIMS AMENDMENTS:** Begins on Page 2

**SPECIFICATION AMENDMENTS:** None

**FIGURES AMENDMENTS:** None

**REMARKS SECTION:** Begins on Page 6